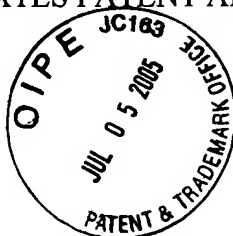


AF *zzw*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 1773
Examiner : Sheeba Ahmed
Serial No. : 10/628,817
Filed : July 28, 2003
Inventors : Hideki Ozawa
: Fumio Aoki
Title : ANTISTATIC FILM AND PROCESS
: FOR ITS MANUFACTURE



Customer No.: 035811

Docket No.: 1259-03

Confirmation No.: 5866

Dated: July 1, 2005

AMENDMENT

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated May 16, 2005, the Applicants amend the Application as follow: